

AMENDMENT TRANSMITTAL LETTER (Large Entity)

Applicant(s): Choung_Hyep et al.

Docket No.

SEC.736D

Application No. 10/822,751	Filing Date April 13, 2004	Examiner Terrell L. McKinnon	Customer No. 20987	Group Art Unit 3743	Confirmation No. 2823
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Invention: APPARATUS FOR AND METHOD OF HEAT-TREATING WAFER

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MAR 15 2005

COMMISSIONER FOR PATENTS:

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	7 -	20 =	0	x \$50.00	\$0.00
INDEP. CLAIMS	1 -	3 =	0	x \$200.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

- No additional fee is required for amendment.
- Please charge Deposit Account No. _____ in the amount of _____
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Signature

Dated: March 15, 2005

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of :

Choung-Hyep Kim et al. : Group Art Unit: 3743

Application No.: 10/822,751 : Examiner: Terrell L. McKinnon

Filed: April 13, 2004 :

APPARATUS FOR AND METHOD OF HEAT-TREATING WAFER

**AMENDMENT AND REQUEST FOR
RECONSIDERATION**

U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

In response to the Office Action dated January 26, 2005, the Applicants submit the following claims amendment, and remarks and arguments regarding the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 5 of this paper.